Analysis of a narrowband terahertz signal generated by a unitravelling carrier photodiode coupled with a dual-mode semiconductor Fabry-Pérot laser

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A narrowband terahertz signal generated by a unitravelling carrier photodiode (UTC-PD) interfaced with a dual-mode Fabry–Pérot laser diode is demonstrated. A beat tone corresponding to the free spectral range is generated on the UTC-PD, and radiated by a transverse-electromagnetic-horn antenna. A terahertz signal at a frequency of 372 GHz, featuring a linewidth of 17 MHz is recorded by a subharmonic mixer coupled to an electrical spectrum analyzer. All components involved in this experiment operate at room temperature. The linewidth and the frequency of the emitted terahertz wave are analyzed, along with their dependency on dc-bias conditions applied to laser diode. © 2010 American Institute of Physics. [doi:10.1063/1.3447931]

Quite recently, it has been demonstrated that semiconductor lasers can produce a terahertz (THz) emission by either using direct^{1,2} or indirect^{3,4} schemes. In the direct generation scheme, the semiconductor lasers used are dc-biased and operate at room temperature (~25 °C). They feature a one-dimensional photonic band gap, introduced by shallow grooves etched on the p-side of the laser junction, perpendicular to the longitudinal axis of the device. These grooves affect the effective refractive index experienced by the electromagnetic wave generated in the active layer. Placement of the grooves at key positions, allow engineering of variations in the refractive index along the laser cavity, and consequently control of the longitudinal spectrum. The Fabry-Pérot (FP) resonance determines an initial spectral separation between consecutive modes but the etched band gap suppresses or enhances some specific FP modes. It is feasible therefore to select modes in order to achieve a given freespectral range. In this emission scheme, an initial design has proven THz emission at 370 GHz, and with the following, generation of a 1.1 THz signal has been indirectly demonstrated.^{1,5} The origin of the THz generation in this context is attributed to the third order intraband nonlinear effects inside laser cavity.

The demonstration of indirect generation, was first performed with dual-mode microchip laser³ at 101.5 GHz, and subsequently with other structures including distributed Bragg reflector laser diode⁴ at 163.5 GHz. They were used to produce an intermediate beat frequency on a low-temperature grown GaAs photodetector.⁶

The linewidth of the THz emission has not been analyzed, independently of the generation scheme used, due to the limitations of the resolution of detection setups. The main objective of this paper is to experimentally investigate the linewidth of the THz signal generated by an indirect technique featuring a slotted FP laser diode and a unitravelling

carrier photodiode (UTC-PD). The THz linewidth should

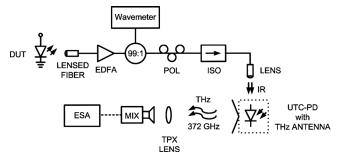


FIG. 1. Experimental setup for the generation and characterization of THz signal. All fiberised and free space components operate at room temperature. Optical fiber is represented with a solid line and electrical path is represented with dashed line.

be in order of the summary linewidth of the optical modes contributing to the generation of such a signal, although it could be further reduced as a result of high coherence of the optical modes originating from a single laser cavity. Our experimental scheme is presented in Fig. 1. Two key components are used to generate a THz signal: a spectrum tailored semiconductor FP laser denoted as a device under test (DUT), and a UTC-PD producing the photomixing at THz frequencies. The detection and the analysis of the THz signal are achieved by a high bandwidth electrical spectrum analyzer (ESA). Along with these components, standard elements for optical tests and measurement techniques are used. The entire setup and its components are placed on an antivibrational optical workbench, and the measurements are carried out at room temperature (\sim 25 °C). DUT is mounted in a standard T0 can. It is a 350 µm long, InAlGaAs multiquantum well based FP laser as previously described in Refs. 1 and 7. Its 2 μ m wide ridge waveguide secures a single mode spatial output. The grooves are 1 μ m deep and span across the ridge. It is characterized by a threshold current of I_{th} =19 mA. Two longitudinal modes located at 1553

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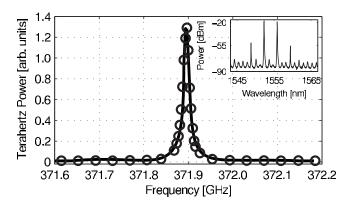


FIG. 2. THz spectrum recorded for the DUT biased at 88.5 mA and temperature controlled at 25 $^{\circ}$ C. Measured data are represented by (\bigcirc), the fitted Lorentzian distribution is represented by a solid line. In inset the optical spectrum recorded with a resolution of 0.02 nm, for the same bias and temperature conditions of the DUT.

and 1556 nm, dominate its emission spectrum. They may be accompanied with lateral modes resulting from four-wave-mixing (FWM), indicating strong nonlinear interactions of optical fields inside the laser cavity. This depends on the bias conditions. However, the optical power unbalance (PU) between the two main modes and the side-bands is greater than 30 dB, suggesting that their direct contribution to the beat signal is negligible. The optical linewidths of the two main modes are in the order of several MHz, which should lead to a THz linewidth of the same order. The UTC-PD is monolithically integrated with a transverse-electromagnetic-horn antenna (TEM-HA) (Refs. 8 and 9) for optimum coupling between the photodetector and the free space. THz generation has been demonstrated up to 1800 GHz with this device.

The infrared output of the DUT is collected by a lensed optical fiber, with 50 μ W of average power coupled. An erbium doped fiber based optical amplifier (EDFA) provides a constant optical output power, set at 13 dBm, the level required for UTC-PD to operate efficiently without bias current provided, after consideration of losses introduced by other elements of the setup. A wavemeter allows continuous monitoring of the spectral output from the DUT. The polarization controller is used to adjust the polarization state of the infrared signal directed onto the UTC-PD. The optical isolator prevents any spurious feedback provided by reflections from the surface of the photodetector. A THz signal is generated on the UTC-PD and propagated via TEM-HA. A polymethylpentene (TPX) based lens, with focal length of 25 mm is used, in order to collect and focus the THz radiation, into a WR-2.8 (260-400 GHz) rectangular metallic waveguide of an active subharmonic mixer (MIX). This mixer is driven by 7-15.5 GHz local oscillator followed by an active multiplier. The intermediate frequency signal at 404.4 MHz is resolved with an ESA, with a resolution bandwidth of 1 MHz and a sweep time of 20 ms, with no averaging. Figure 2 shows a record of the THz signal generated with this setup. The DUT is biased at 88.5 mA and temperature controlled at 25 °C and no noticeable central frequency fluctuations were observed in a few minutes timescale. In the inset, under the same operating conditions, the optical spectrum recorded at the laser output is presented. It is possible to generate a THz signal using the indirect scheme, based on the multimode semiconductor laser and the UTC-PD photo-

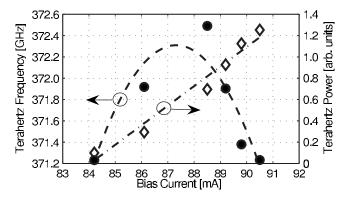


FIG. 3. Power of THz signal generated (ullet) and its central frequency (\Diamond) as a function of bias current applied to the laser diode. The dashed lines are eye-guides.

detector. The THz signal can be fitted with a Lorentzian shape, exhibiting a central frequency at 371.895 GHz, and a linewidth of (16.89 ± 0.12) MHz. This frequency corresponds to the free spectral range between the main optical modes as depicted in the inset of Fig. 2. It is possible to achieve narrower THz linewidth by using two single mode external cavity lasers (ECL) as the optical mode sources, which are characterized by the optical linewidths in the order of 100 kHz. However, such a scheme is prone to the central frequency fluctuations which arise from thermal and mechanical instabilities. An active phase-locking setup allowing to overcome these effects, 11 would mostly confine it to a laboratory environment. The impact of such instabilities, if present, in the case of a monolithic dual-mode laser diode is negligible, as both modes simultaneously experience the same fluctuations. Therefore with our device, the central frequency of the THz wave exhibits virtually no shift when recorded at given experimental conditions, as opposed to the one achieved with two ECL sources where the measured values are sweep time dependant due to such instabilities. Furthermore, the linewidth of the THz signal can benefit from the coherence of the optical modes emitted by our laser diode, enhanced via intracavity FWM, which is not the case with two independent single mode sources, as their phases are uncorrelated. Such a THz spectrum has been recorded as a function of the bias current applied to the DUT, while its temperature is maintained at 25 °C. Figure 3 compiles the central frequency of the recorded THz signal and the estimated power associated with THz peak for a range of bias between 84 and 91 mA. Outside this current range, it is not possible to detect and to resolve the THz signal. The power is expressed in arbitrary unit as it was difficult to evaluate the loss between the free space THz emission and the waveguide coupling. A linear dependence with positive slope of central frequency is clearly observed, across a 1200 MHz tuning range. This behavior can be linked to the variation in the group refractive index of the active layer. As the bias current increases, the carrier density in the active layer increases. By plasma effect the group refractive index is reduced. The free spectral range increases and therefore the beat frequency also increase. The THz signal power increases with bias current, until it reaches a maximal value for a bias of 89 mA. The power decreases with further increase in current. If we keep in mind that the optical power launched into the UTC-PD is constant, this THz power variation is due a variation in the spectrum of the dual-mode laser. Furthermore, the linewidth

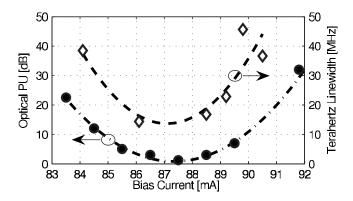


FIG. 4. Optical power unbalance (\bullet) and THz linewidth (\diamond) as a function of bias current applied to the laser diode. The dashed lines are eye-guides.

of the THz signal as function of the bias current and the PU between the two dominant optical modes for the same bias range are plotted in Fig. 4. Outside the range of bias current between 84 and 91 mA, where the THz emission occurs, the PU is larger than 20 dB. At 83.5 mA the dominant mode is at 1553 nm while at 92 mA, it is at 1556 nm. The spectral purity of the THz signal appears to be linked to the PU. In the investigated bias range both quantities seem to follow a similar trend, achieving minimal values at the same bias current. This can be understood by the fact that in these optical spectral conditions, the coherence of the optical modes is enhanced. The intracavity FWM contributes to reduce the phase noise of each mode, and therefore their linewidth.

In this paper, we demonstrated the generation of a narrowband THz signal based on a spectrum tailored semiconductor FP laser and a UTC-PD, at room temperature. The key feature of this scheme lies in the stability and the quality of the THz signal achieved. The THz wave generated is measured at 371.9 GHz, with a tunability of 1200 MHz for a variation in the bias current in a range from 84 to 91 mA. Its linewidth is measured at 17 MHz which corresponds to the order of the linewidths associated with the optical modes. Results of the order of 10 kHz have been achieved with glass lasers, 12 however they are complex, need centimeter-long cavity with precise and stable mechanics, and offer a lower

efficiency due to optical pumping. For applications compatible with megahertz linewidths semiconductor lasers are more compact and cost effective. It should be noted that if the optical coupling between the laser and the fiber is enhanced the EDFA could be removed from the setup. In this case a very compact, light-weight, and possibly battery operated THz source can be achieved.

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